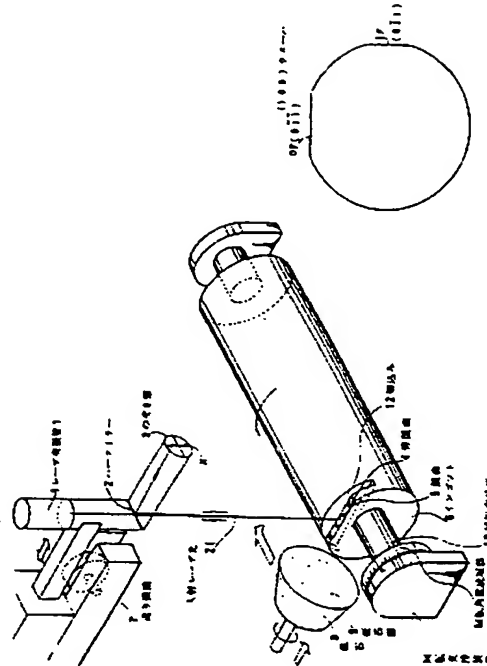


# Patent Abstracts of Japan

TITLE : METHOD AND APPARATUS FOR  
FORMING ORIENTATION FLAT  
SURFACE OF COMPOUND  
SEMICONDUCTOR



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